



AF/2881

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Kouchi Nagai et al.

Confirmation Number: **4556**

Serial No.: **09/815,282**

Group Art Unit: **2881**

Filed: **March 23, 2001**

Examiner: **Paul Gurzo**

For: **SCANNING ELECTRON MICROSCOPE**

Attorney Docket: **010391**

STATEMENT OF SUBSTANCE OF INTERVIEW

Commissioner for Patents, P.O. Box 1450
Alexandria, VA 22313-1450
Sir:

Date: **December 10, 2003**

A complete reply will follow. The Applicants now submit the required statement of the substance of the personal interview of November 12, 2003, as follows:

The working order of instant application and teaching of ranges in the prior art was discussed.

Respectfully submitted,

ARMSTRONG, KRATZ, QUINTOS
HANSON & BROOKS, LLP

Nick Bromer

Nick Bromer
Registration No. 33,478
(717) 426-1664, voice and fax

RECEIVED
DEC 16 2003
TECHNOLOGY CENTER 2800

Address: Atty. Docket 010391
Armstrong, Westerman & Hattori, LLP
1725 K Street, NW
Suite 1000
Washington, DC 20006

(202) 659-2930, voice; (202) 887-0357, fax

Q:\nick bromer\010391.oa2